



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known


Application Number	10/628,188
Filing Date	July 28, 2003
First Named Inventor	Fechko et al.
Art Unit	1765
Examiner Name	
Attorney Docket Number	5000.302

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

Examiner Signature		Date Considered	10/11/2005
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Substitute for form ~~4-6800~~

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 2

Complete if Known


Application Number	10/628,188
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First Named Inventor	Fechko et al.
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[illegible]

FOREIGN PATENT DOCUMENTS

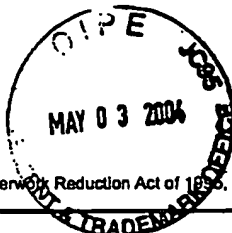
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	†
		Country Code ³ Number ⁴ Kind Code ⁶ (if known)				
M)	8	EP 0 561 462 A2	09-22-1993	Philips Electronics		
M)	9	WO 97/28297 A1	08-07-1997	Cree Research, Inc.		
M)	10	WO 90/00817 A1	01-25-1990	Raychem Limited		

Examiner Signature		Date Considered	10/11/2005
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PTO/SB/08b (08-03)

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				Application Number	10/628,188
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				Art Unit	1765
Sheet	2	of	2	Examiner Name	
				Attorney Docket Number	5000.302

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T ²
M)	11	T. FURUSHO ET AL.; Crystal growth of silicon carbide in hydrogen atmosphere by sublimation close space technique; Journal of Crystal Growth (2002); Vol. 237-239; pages 1235-1238; Elsevier Science B.V.		
	12	S.K. LILOV ET AL.; Studies of Growth Processes in Silicon Carbide Epitaxial Layers from the Vapour Phase; Journal of Crystal Growth (1976); Vol. 32; pages 170-178; North-Holland Publishing Company		
	13	I.G. IVANOV ET AL.; Nitrogen doping concentration as determined by photoluminescence in 4H- and 6H- SiC; Journal of Applied Physics; September 15, 1996; Vol. 80, No. 6; pages 3504-3508; American Institute of Physics		
M)	14	PETER RABACK ET AL.; Thermodynamic Considerations of the Role of Hydrogen in Sublimation Growth of Silicon Carbide; Journal of Electrochem. Soc.; March 1997; Vol. 144, No. 3; pages 1024-1027; The Electrochemical Society, Inc.		

Examiner Signature	<i>Math J</i>	Date Considered	10/18/2005
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